

Application/Control No.	Applicant(s)/Patent under Reexamination
10/574,687	MORITA ET AL.
Examiner	Art Unit
Taeyoon Kim	1651

SEARCHED					
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST search (USPG- pub;USPAT;USOCR;EPO;JPO;Derwe nt)	7/9/2008	тк
Pubmed (keyword: patterning, polylysine, cell adhesion)	7/9/2008	TK
Inventor search (PALM)	7/11/2008	TK